



INFORMATION  
DISCLOSURE  
STATEMENT BY APPLICANT

Sheet 1 of 1

Application Number: 10/646,467  
Filing Date: August 22, 2003  
First Named Inventor: Kenneth COLLINS, et al.  
Group Art Unit: ~~Unknown~~ 2812  
Examiner Name: ~~Unknown~~ GHYKA  
Attorney Docket Number: 6915 P06

U. S. PATENT DOCUMENTS

Examiner Initials	Document No	Publication Date	Name of Patentee or Applicant of Cited Document	Class	Subclass	Filing Date
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NON PATENT LITERATURE DOCUMENTS

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AG	Van de Ven, Evert P., Connick, I-Wen, and Harrus, Alain S., "ADVANTAGES OF DUAL FREQUENCY PECVD FOR DEPOSITION OF ILD AND PASSIVATION FILMS," IEEE, Proceedings of VMIC Conference, June 12-13, 1990, pp. 194-201.

Examiner's Signature:

*AG*

Date Considered:

7/7/07

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.